



电子科技大学
University of Electronic Science and Technology of China

MMT

微波毫米波集成电路与系统实验室
Microwave and Millimeter-wave Technology(MMT) Lab

Modeling the Linearity of III-V Semiconductor RF Transistors

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Outline

I. Background

II. EEHEMT GaAs LSM

III. QPZD GaN LSM

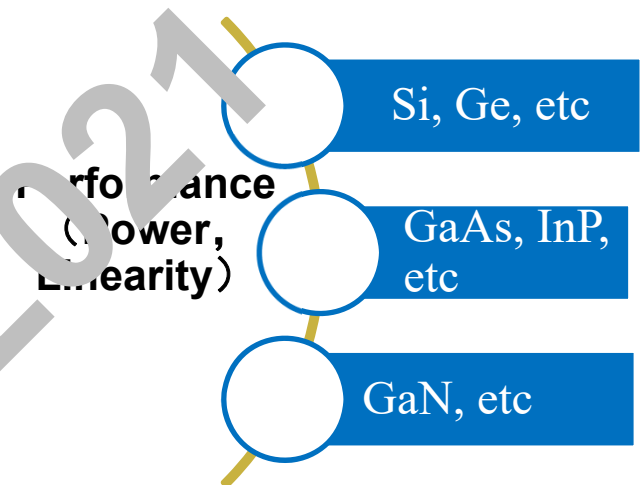
IV. Summary



Background

RF Transistors development

Parameter	Diamond	BN	Ga ₂ O ₃	AlN	GaN	SiC	GaAs	Si
σ_{thermal} (W/m·K)	2,290 - 3,450	~10 - 20	11 - 27	319	≤ 253	370	55	145
e ⁻ mobility (cm ² /V·s)	4,500	~800	180	426	2,260	900	8,500	1,450
hole mobility (cm ² /V·s)	3,800	~500	--	--	24	120	400	480
E _{breakdown} (MV/cm)	~13.0	~17.5	~10.3	~15.4	~4.9	~3.0	~0.4	~0.3
v _{sat} (10 ⁷ cm/s)	2.3 (e ⁻) 1.4 (h ⁺)	--	1.1	1.3	1.4	2.0	1.0	1.0
Rel. permittivity	5.7	7.1	10.0	9.8	10.4	9.7	12.9	11.8

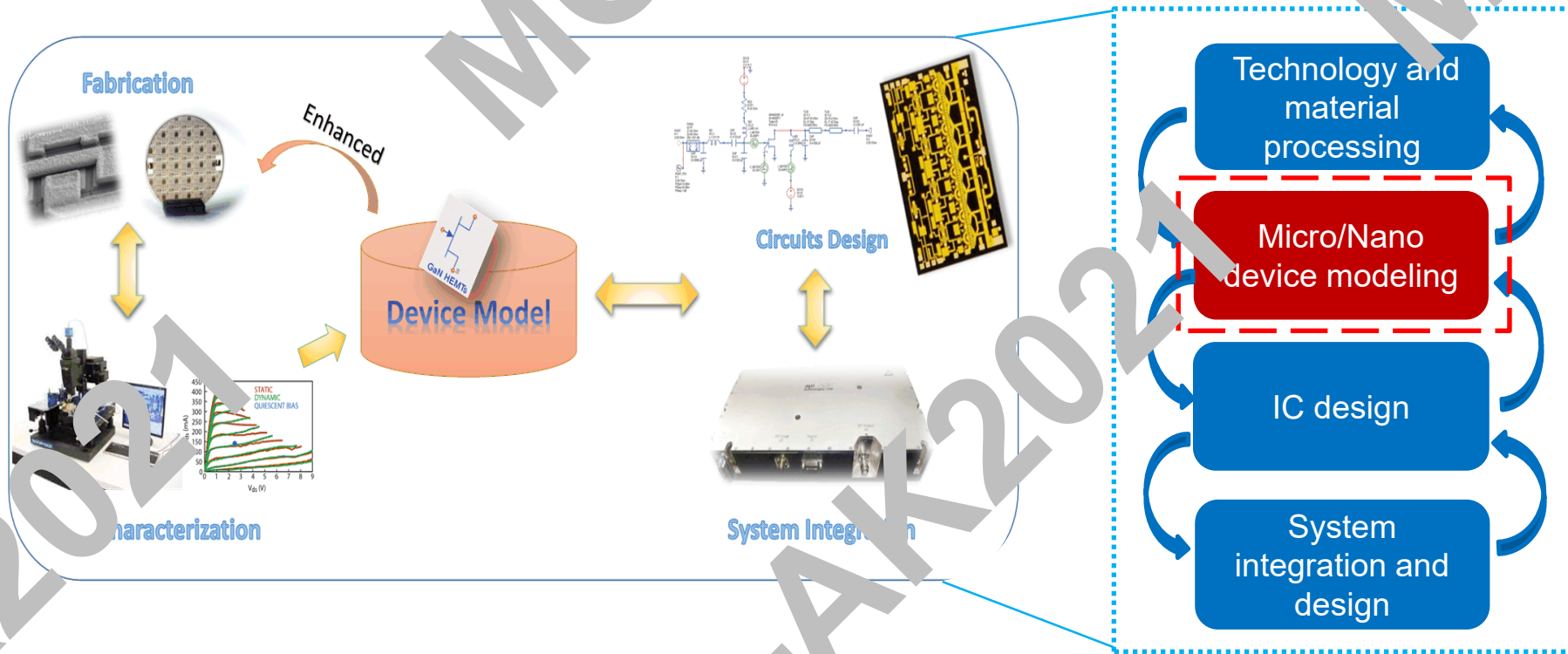


- 5G communication has higher requirements for linearity
- Device with high output power and efficiency



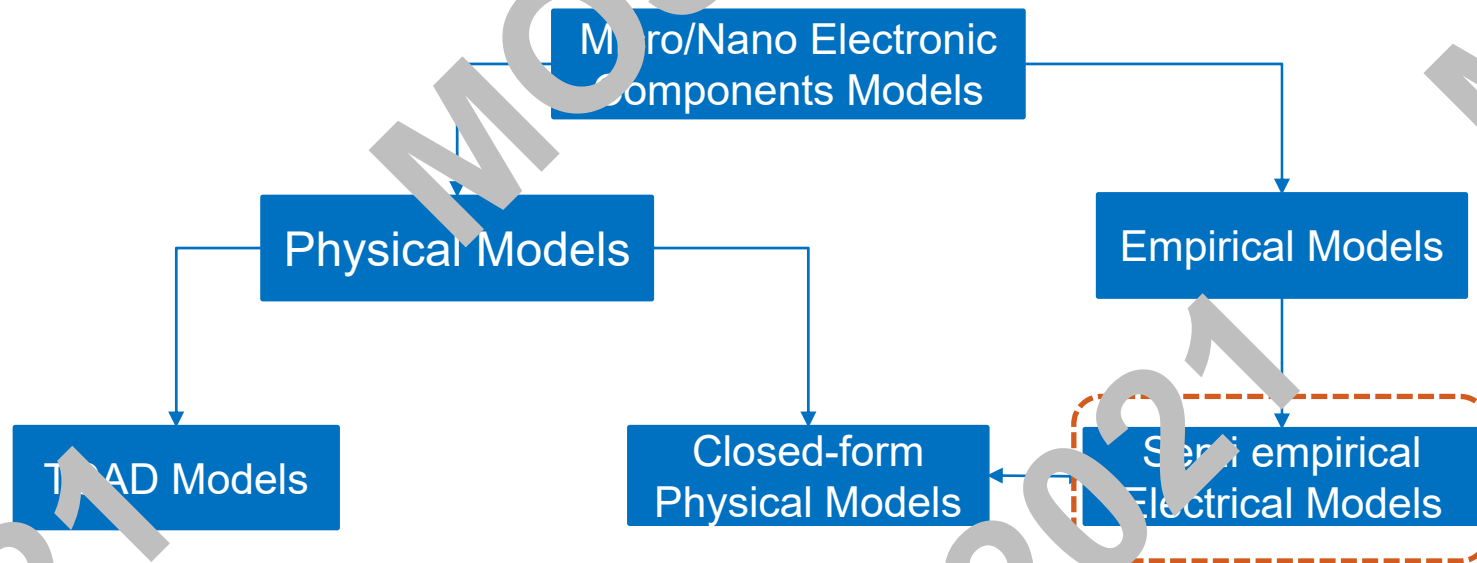
Background

Importance of device modeling





Background



GaN HEMT: QPZD model

GaAs HEMT: EEHEMT model

QPZD: Quasi-physical zone division



Outline

I. Background

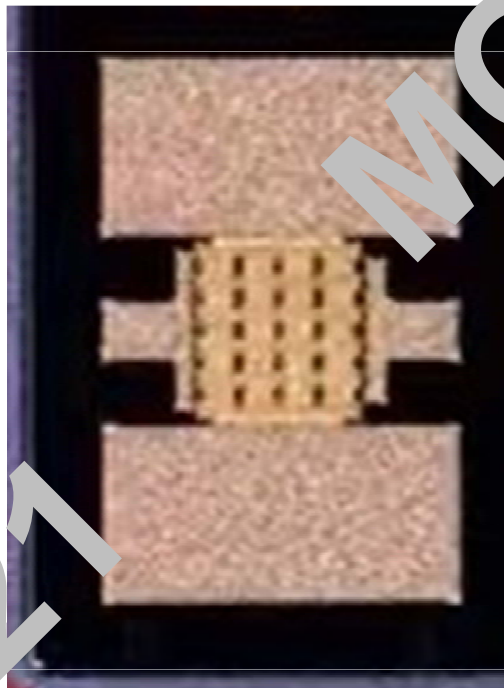
II. EEHEMT GaAs LSM

III. QPZD GaN LSM

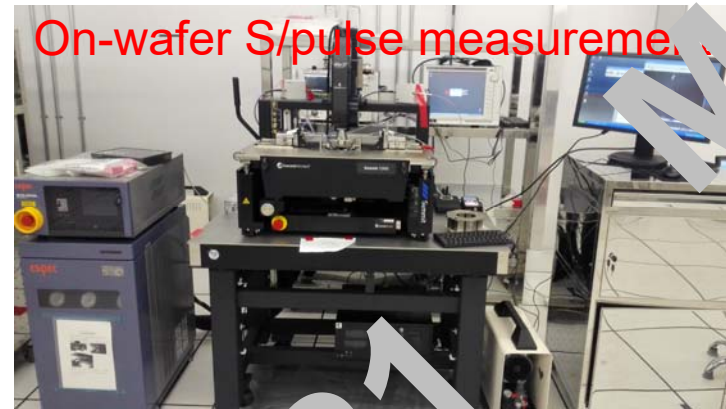
IV. Summary



EEHEMT GaAs LSM



10×100 μm GaAs HEMT (0.25 μm)



On-wafer S/pulse measurement



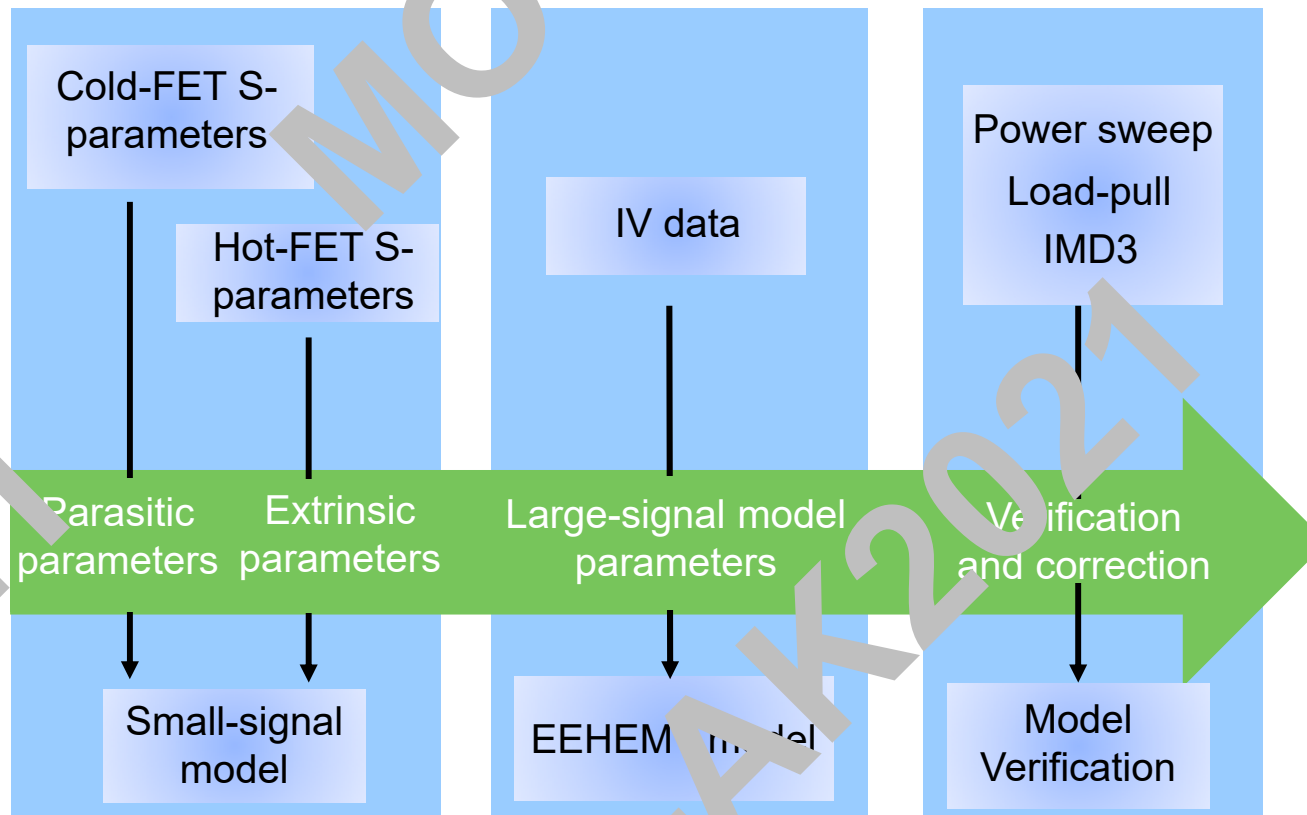
50 GHz load-pull system

device measurement platform



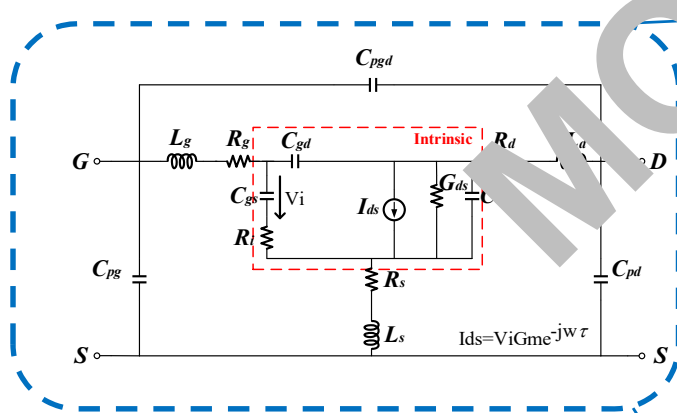
EEHEMT GaAs LSM

EEHEMT parameters extraction flow



EEHEMT GaAs LSM

Small-signal model parameters extraction



➤ Parasitic Parameters

- Parasitic capacitance C_{pg} , C_{pd} , C_{pgd}
- Parasitic inductance L_g , L_d , L_s
- Parasitic resistance R_g , R_d , R_s

➤ Intrinsic Parameters

- C_{gs} , C_{gd} , C_{ds} , R_i , g_m , τ , g_{ds}

Small-signal Model

Parasitic Parameters

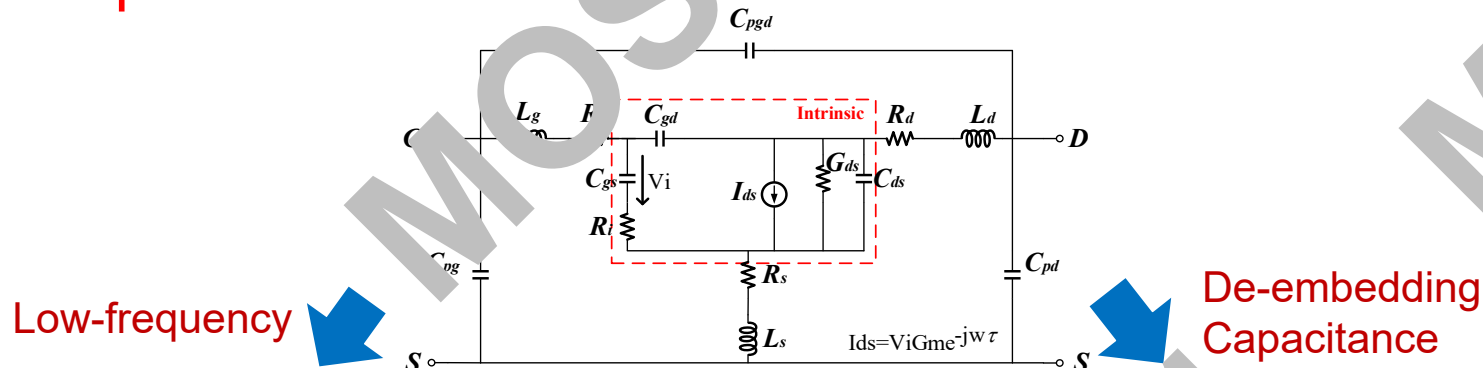
1. Extract C_{pd} , C_{pg} , C_{pgd}
 - From Cold-Pinchoff S-parameters
 - at low frequencies
2. Extract L_g , L_d , L_s
 - From Cold-Pinchoff Z-parameters
 - at high frequencies
3. Extract R_g , R_d , R_s
 - From Cold-Pinchoff Z-parameters

Intrinsic Parameters

- Extract C_{gs} , C_{gd} , C_{ds} , R_i , g_m , τ , g_{ds}
- From Hot-FET Y-parameters

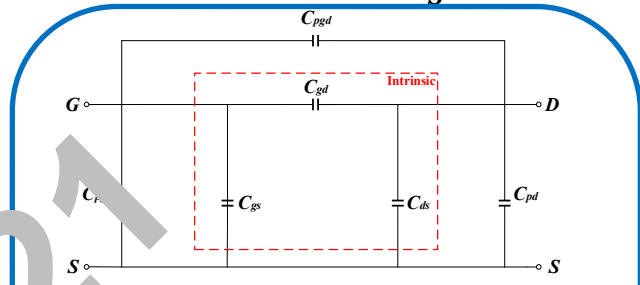
EEHEMT GaAs LSM

Parasitic parameters extraction



Low-frequency

De-embedding Capacitance



$$C_{gdo} = C_{pgd} + C_{gd}$$

$$C_{gso} = C_{pg} + C_{gs}$$

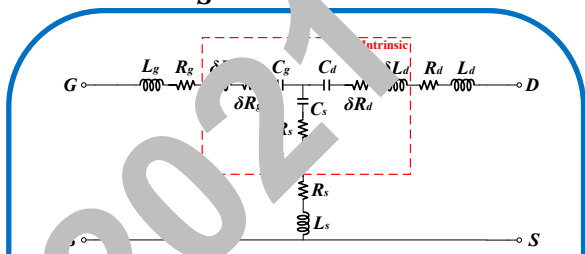
$$C_{dso} = C_{pd} + C_{ds}$$

$$Y_{11} = j\omega(C_{gso} + C_{gdo})$$

$$Y_{22} = j\omega(C_{dso} + C_{gdo})$$

$$Y_{12} = Y_{21} = -j\omega C_{gdo}$$

- assuming $C_{pg} = C_{pd}$
- scanning C_{pg} and C_{pgd}



$$Im(\omega Z_{11}) = (L_g + L_s)\omega^2 - \left(\frac{1}{C_{g1}} + \frac{1}{C_s}\right)$$

$$Im(\omega Z_{22}) = (L_d + L_s)\omega^2 - \left(\frac{1}{C_d} + \frac{1}{C_s}\right)$$

$$Im(\omega Z_{11}) = L_s\omega^2 - \frac{1}{C_g}$$

$$\omega^2 Re(Z_{11}) = \omega^2(R_g + R_s)$$

$$\omega^2 Re(Z_{22}) = \omega^2(R_d + R_s)$$

$$\omega^2 Re(Z_{12}) = \omega^2 R_s$$

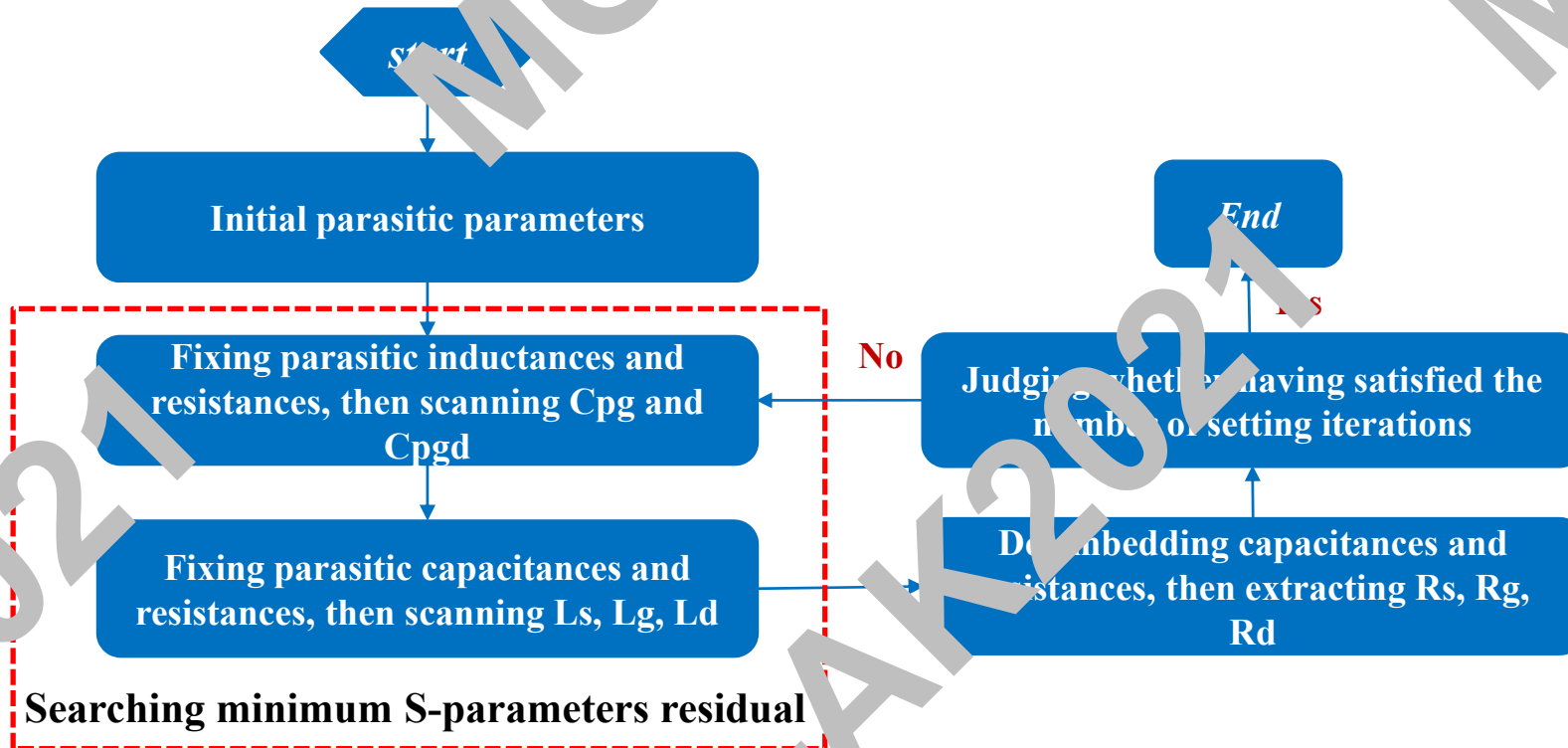
- L -the slope of $Im(\omega Z) - \omega^2$
- R -the slope of $\omega^2 Re(Z) - \omega^2$



EEHEMT GaAs LSM

Parasitic parameters extraction

- Optimization algorithm



EEHEMT GaAs LSM

Intrinsic parameters extraction

- De-embedding extrinsic parameters including C_{pg} , C_{pd} , C_{pgd} , L_g , L_d , L_s , R_g , R_d and R_s
- Using following equations to extract intrinsic parameters

$$d(\omega_i) = \frac{Re(Y_{11}(\omega_i) + Y_{12}(\omega_i))}{Im(Y_{11}(\omega_i) + Y_{12}(\omega_i))}$$

$$c(\omega_i) = (Y_{21}(\omega_i) - Y_{12}(\omega_i))(1 + jd(\omega_i))$$

$$R_i(\omega_i) = \frac{d^2(\omega_i)}{(1 + d^2(\omega_i))Re(Y_{11}(\omega_i) + Y_{12}(\omega_i))}$$

$$g_m(\omega_i) = |c(\omega_i)|$$

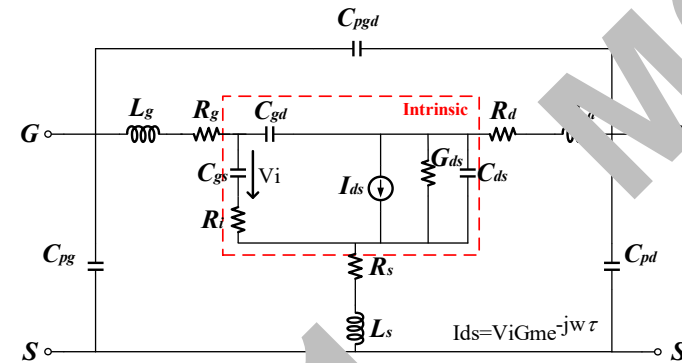
$$\theta_c(\omega_i) = -\frac{1}{\omega_i} \arctan\left(\frac{Im(c(\omega_i))}{Re(c(\omega_i))}\right)$$

$$Y_{22}(\omega_i) = Re(Y_{22}(\omega_i) + Y_{12}(\omega_i))$$

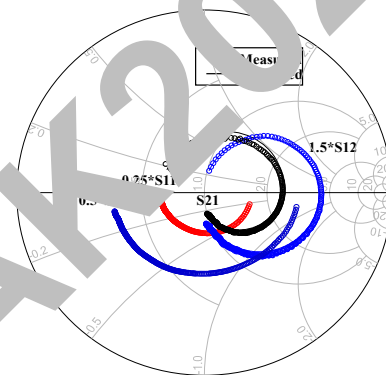
$$C_{ds}(\omega_i) = \frac{Im(Y_{22}(\omega_i) + Y_{12}(\omega_i))}{\omega_i}$$

$$C_{gd}(\omega_i) = -\frac{Im(Y_{12}(\omega_i))}{\omega_i}$$

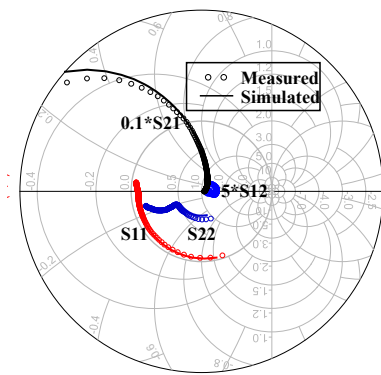
$$C_{gs}(\omega_i) = \frac{1 + d^2(\omega_i)}{\omega_i} Im(Y_{11}(\omega_i) + Y_{12}(\omega_i))$$



Result



Vds=2V, Vgs=0.2V



Vds=4V, Vgs=0.5V



EEHEMT GaAs LSM

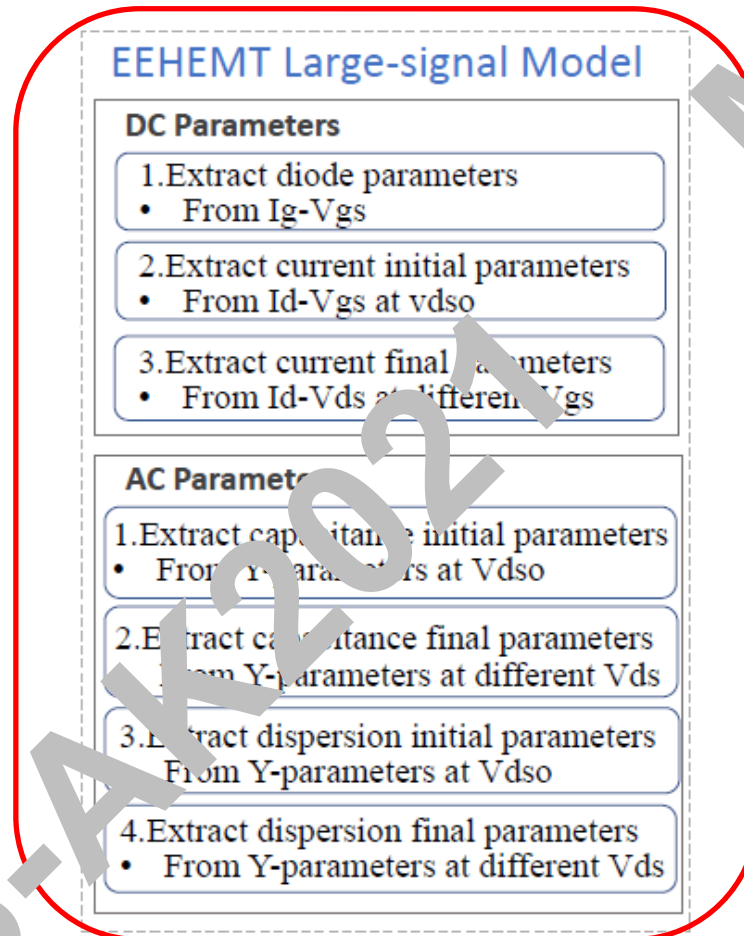
EEHEMT large-signal model parameters extraction

➤ DC Parameters

- Diode parameters
- Drain-source current parameters

➤ AC Parameters

- Capacitance parameters
- Dispersion parameters

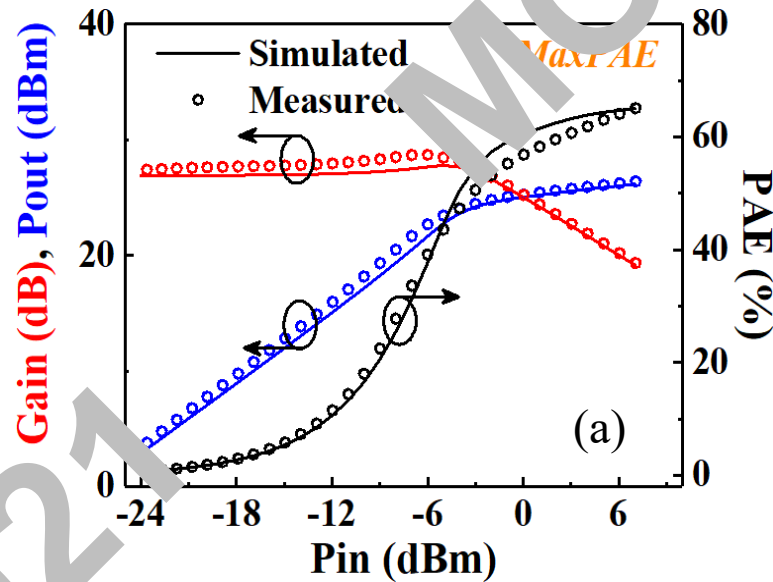




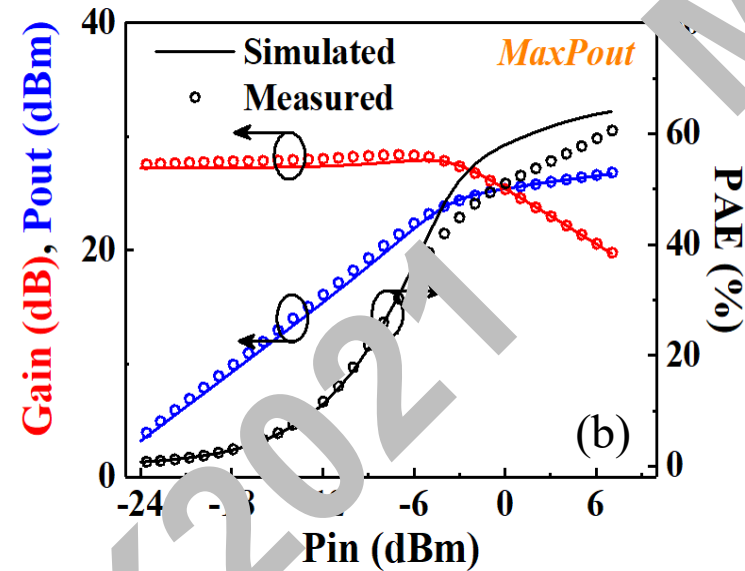
EEHEMT GaAs LSM

Model verification

- RF performance(one-tone excitation)



(a) at maximum PAE matching



(b) at maximum Pout matching

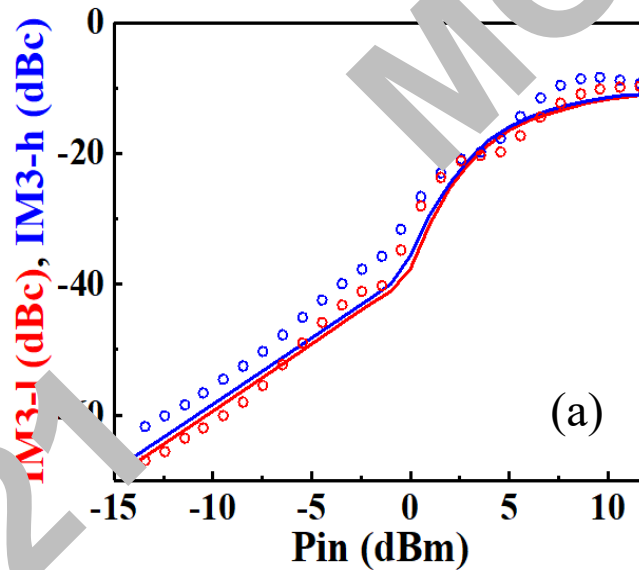
($V_{ds}=5V; V_{gs}=0.5V; freq=1.8 GHz$)



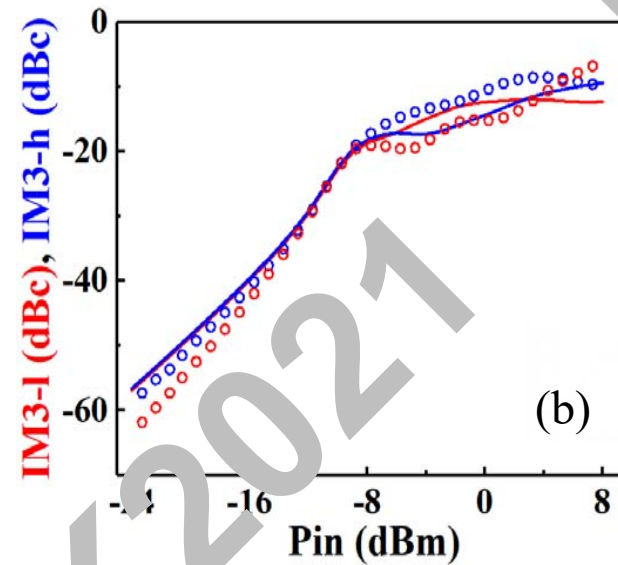
EEHEMT GaAs LSM

Model verification

- RF performance(two-tone excitation)



(a) at 50 Ohm impedances matching



(b) at maximum Pout matching

($V_{ds} = 5V; V_{gs} = 0.5V, freq = 1.8 GHz \pm 5 MHz$)



Outline

I. Background

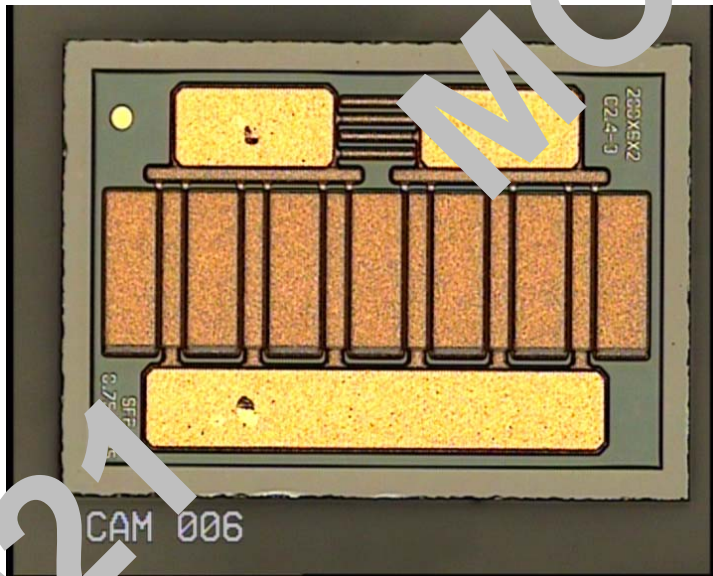
II. EEHEMT GaAs LSM

III. QPZD GaN LSM

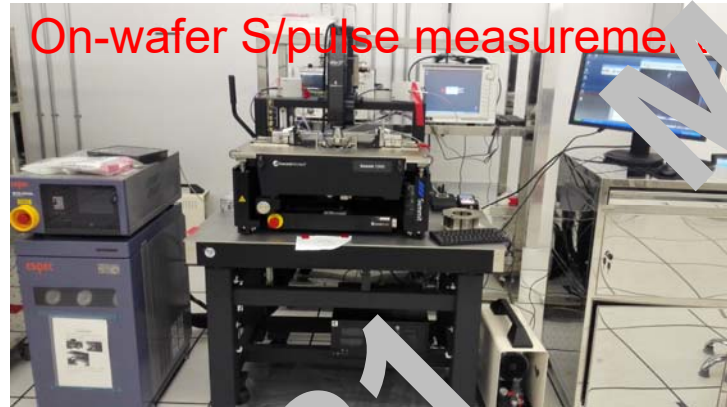
IV. Summary



QPZD GaN HEMT



12 × 200 μm GaN HEMT (0.4 μm)



On-wafer S/pulse measurement

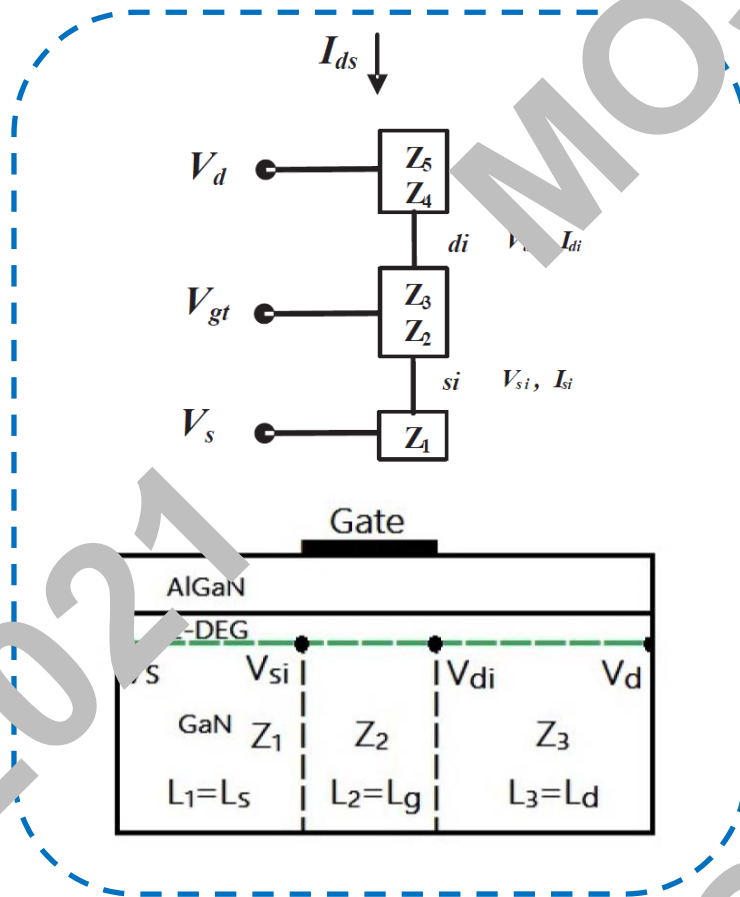


50 GHz loop-pi system

device measurement platform

QPZD GaN HEMT

QPZD(Quasi-physical zone division) model introduction



➤ **Less fitting parameters (i.e. Angelov model)**

$$I_{ds} = \frac{I_{max} V_{ds} (1 - \lambda V_{ds})}{\sqrt{\beta} E_c^\beta (l_s + l_d)^\beta + (E_c l_g + V_{ds})^\beta}$$

$$I_{max} = W q n_s (V_{gs}) v_{max}$$

$$n_s = 0.5 n_{smax} \cdot \tanh(\alpha_1 \cdot (V_{gs} - V_{off})^3 + \alpha_2 \cdot (V_{gs} - V_{off})^2 + \alpha_3 \cdot (V_{gs} - V_{off}) + \beta_1) + 0.5 n_{smax}$$

$$\mu = (a_0 + a_1 T_{ch}) (b_0 + b_1 T_{ch} + b_2 T_{ch}^2)$$

$$T_{ch} = T_0 + I_{ds} V_{ds} P_{diss}$$

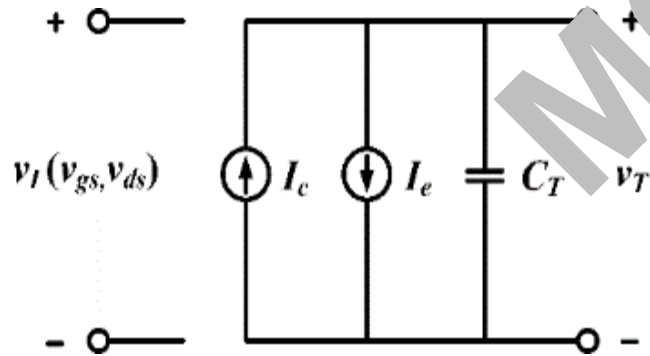
$$E_c = \frac{v_{sat}}{\mu}$$

➤ **Natural scale**



QPZD GaN HEMT

Modeling trapping effect using SRH model



$$v_T = \frac{V_0}{1 + \exp\left(\frac{v_i}{kT}\right)}$$

$$v_i = AV_{GS} + BV_{DS} + C$$

V_0 [V]: trap potential when it is fully ionized

T [K]: temperature

k [eV/K]: the Boltzmann constant

A [V]: the trap-control potential

v_T [V]: the calculated effective trap potential

➤ Using SRH(Shockley-Read-Hall) model to model the trapping effect

- characterizing the electron capture and emission in the trap center
- dynamic trapping effect can be considered

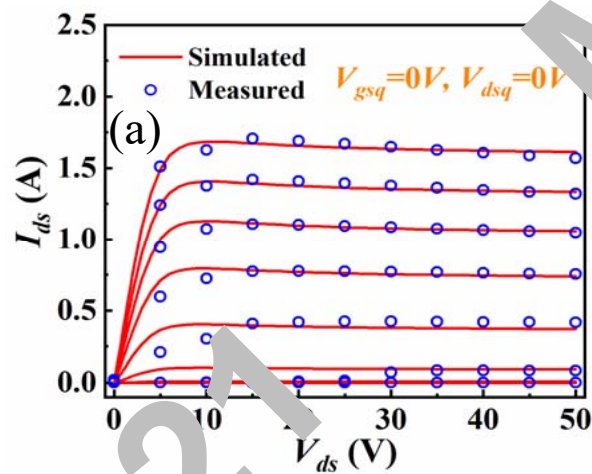
➤ A sub-network is used for describing the dynamic process



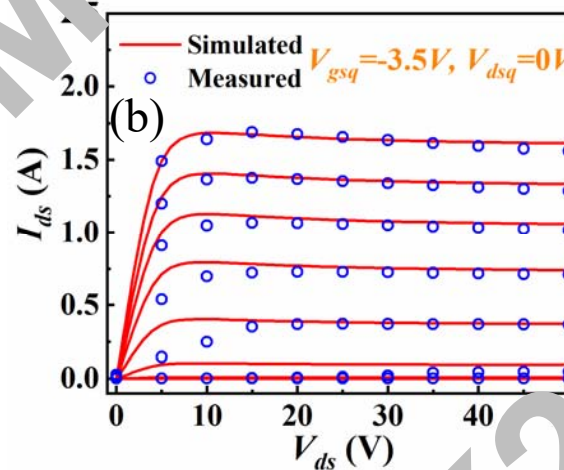
QPZD GaN HEMT

Model verification

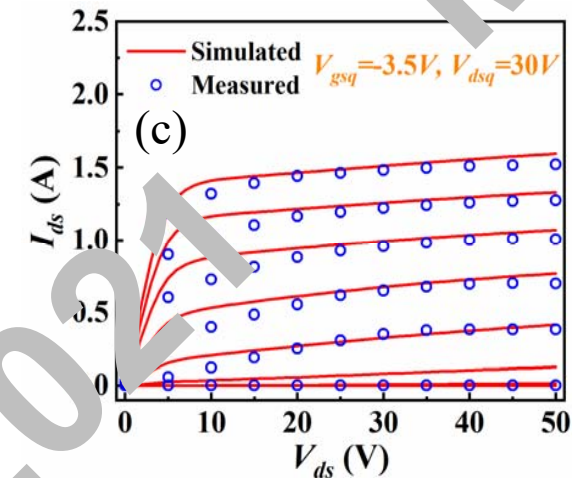
➤ Pulse IV



(a) $V_{gsq} = 0V$, $V_{dsq} = 0V$



(b) $V_{gsq} = -3.5V$, $V_{dsq} = 0V$



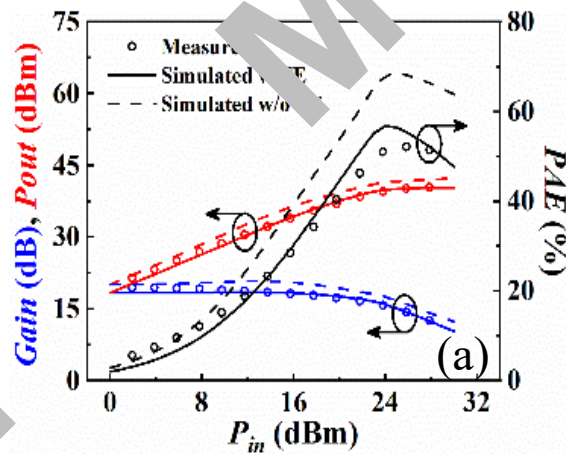
(c) $V_{gsq} = -3.5V$, $V_{dsq} = 30V$



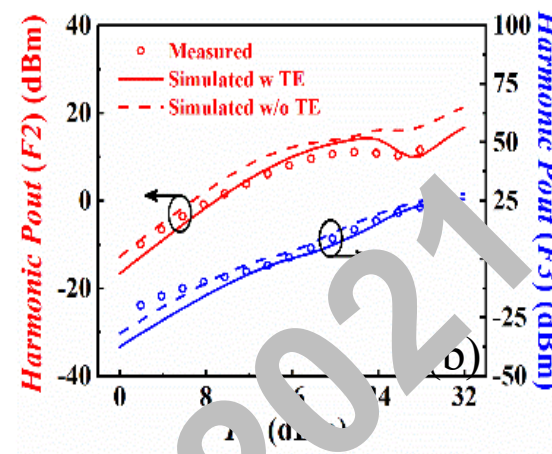
QPZD GaN ESLM

Model verification

- RF performance (one-tone excitation)



(a) fundamental output performance



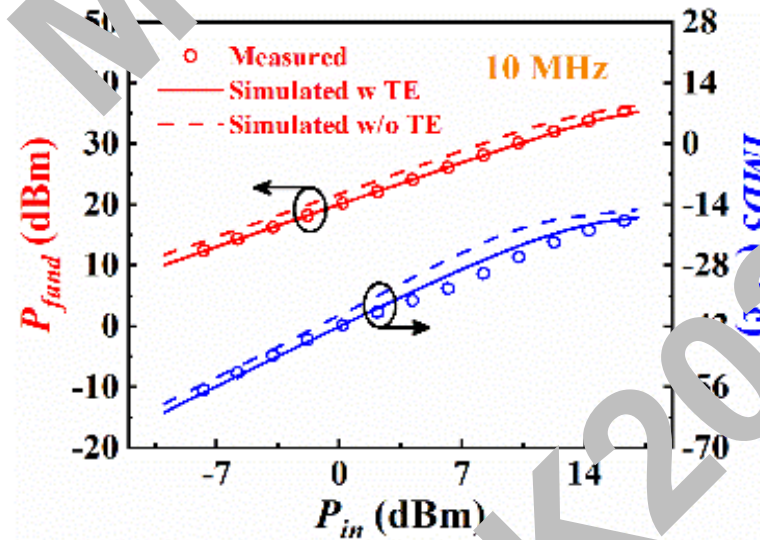
(b) second and third harmonic output performance



QPZD GAN LSM

Model verification

- RF performance(two-tone excitation)



P_{out} and IMD3 characteristics



Outline

I. Background

II. EEHEMT GaAs LSM

III. QPZD GaN LSM

IV. Summary



Summary

- Present an improved small-signal model parameters extraction method and establish the EE-HEMT large-signal model. Results show it accurately characterizes the radio frequency characteristics of GaAs HEMT
- Introduce an improved QPZD large-signal model using the SRH trap model to model the trapping effect for GaN HEMT. Model validation results show that it can accurately characterize RF performance



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Thank you!